E /		Application No.		09/767,659
TRANSMITTAL FORM		Filing Date		January 22, 2001
		First Named Inventor Examiner Name		Richard N. SAVAGE FOX, Charles A.
Total Number of Pages in This Submission 7		Attorney Docket No.		A-67736-1/MSS/TJH 463035-19
	ENCL	OSURES (che	ck all th	at apply)
Fee Transmittal Form	Assignme (for an Ap	ent Papers oplication)		After Allowance Communication to Group
Fee Attached	Drawing(s)			Appeal Communication to Board of Appeals and Interferences
Amendment / Reply	Licensing-related Papers			Appeal Communication to Group (Appeal Notice, Brief, Reply Brief)
After Final	Petition			Proprietary Information
Affidavits/declaration(s)	Petition to Convert to a Provisional Application			Status Letter
Extension of Time Request	Power of Attorney, Revocation Change of Correspondence Address			Other Enclosure(s) (please identify below):
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Certified Copy of Priority Document(s)	CD, No. o	of CD(s)		
Response to Missing Parts/	Remarks			
Incomplete Application Response to Missing Parts under 37 CFR 1.52 or 1.53				•
	OF APPLICAN	IT, ATTORNEY, (OR AGI	ENT
Firm 4 Embarcadero Center, S or San Francisco, CA 9411	Tianjun Hou DORSEY & WHITNEY LLP 4 Embarcadero Center, Suite 3400 San Francisco, CA 94111 Telephone: 415 781 1989		omer l	Number 32940
Signature Parhifor			-	
Date April 20, 2005		······		
	CERTIFICATE	OF MAILING		

Copied from 10767659 on 06/06/2005

Signature 1087697 Date

PPW

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U.S. Serial No.: 10/769,659

CERTIFICATE MAIL (37 CFR 1.8(a))

Thereby certify that this correspondence, including listed enclosures, is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on: 2005.

Laura Lee Mosier

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Richard N. Savage, et al.

Serial No.:

10/767,659

Filed:

January 22, 2001

For:

Semiconductor Wafer Processing system with

Vertically-Stacked Process Chambers and Single-Axis Dual Wafer Transfer System

Examiner: FOX, CHARLES A

Art Unit: 3652

AMENDMENT UNDER 37 CFR § 1.111

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Applicants have considered the non-final Office Action mailed January 25, 2005 in the above-captioned application and request reconsideration of the claims in light of the claim amendments and the remarks that follow.

Amendment to the Claims are reflected in the listing of claims which begin on page 2 of this Amendment.

Remarks begin on page 5 of this Amendment.